Electronic Acknowledgement Receipt				
EFS ID:	5238791			
Application Number:	10562236			
International Application Number:				
Confirmation Number:	3799			
Title of Invention:	Manufacturing method of silicon wafer			
First Named Inventor/Applicant Name:	Sakae Koyata			
Customer Number:	07055			
Filer:	Stephen M. Roylance/Liping Qi			
Filer Authorized By:	Stephen M. Roylance			
Attorney Docket Number:	JG-SU-5222/500577.20072			
Receipt Date:	29-APR-2009			
Filing Date:	07-FEB-2007			
Time Stamp:	13:25:19			
Application Type:	U.S. National Stage under 35 USC 371			
Payment information:				

yes
Credit Card
\$180
8513
-

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /₊zip	Pages (if appl.)
--------------------	----------------------	-----------	-------------------------------------	---------------------	---------------------

	1	i	<u> </u>							
1		p35794- amend ment 1111 and IDS.pdf	4008889	yes	67					
			0b64fab4c7ac6f63ffcde1217c613cca87d99 7f6		07					
	Multipart Description/PDF files in .zip description									
	Document De	Document Description		End						
	Amendment/Req. Reconsideration-After Non-Final Reject		1	10						
	Information Disclosure Statement (IDS) Filed (SB/08)		11	39						
	Foreign Reference		40	44						
	Foreign Reference		45	51						
	Foreign Reference		52	58						
	Foreign Reference		59	67						
Warnings:										
Information										
2	2 Fee Worksheet (PTO-875)	fee-info.pdf	30162	no	2					
2 Teewo		.555,55	aa330c912f36246faf28af82e61fc702dd64f 89a							
Warnings:										
Information:										
	Total Files Size (in bytes)			4039051						

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.